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March 15, 2004

MAIL STOP PATENT APPLICATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Re:

Application of Shigeru NAKAMURA

PROCESS FOR PREPARATION OF RARE EARTH SILICATE PHOSPHOR

Assignee: FUJI PHOTO FILM CO., LTD.

Our Ref. Q80444

Dear Sir:

Attached hereto is the application identified above comprising forty-six (46) sheets of the specification, including the claims and abstract. Copies of the executed Declaration and Power of Attorney and Assignment will be submitted at a later date.

The Government filing fee is calculated as follows:

TOTAL FEE \$770.00

A check for the statutory filing fee of \$770.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this transmittal letter is attached.

Priority is claimed from:

Country

Application No

Filing Date

Japan

2003-70441

March 14, 2003

The priority document enclosed herewith.

Since the anniversary of the priority date fell on a Sunday the filing of this application on Monday, March 15, 2004 is sufficient to obtain the benefit of priority.

Respectfully submitted, SUGHRUE MION, PLLC

Attorneys for Applicant

Bv:

Joseph J. Ruch, Jr. Registration No. 26,577

Telephone: (202) 293-7060 Facsimile: (202) 293-7860

SUGHRUE MION, PLLC

WASHINGTON OFFICE

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